



In re Application of:

HITOSHI NAKANO

Application No.: 09/536,637

Filed: March 28, 2000

For: APPARATUS WITH AIR-CONDITIONING  
SYSTEM, AND DEVICE MANUFACTURING  
METHOD USING THE SAME

Docket No.: 684.2985

Examiner: L. Ceric

Group Art Unit: 3743

Date: October 9, 2001

COMMISSIONER FOR PATENTS  
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	19	MINUS	20	= 0	x \$9 \$18	\$ -0-
INDEP. CLAIMS	2	MINUS	3	= 0	x \$42 \$84	\$ -0-
Fee for Multiple Dependent claims \$140°/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ -0-

°Verified Statement claiming small entity status is enclosed, if not filed previously.

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TC 3700 MAIL ROOM

A check in the amount of \$\_\_\_\_ is enclosed.

Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

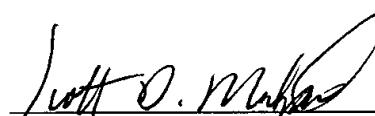
Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

A check in the amount of \$\_\_\_\_\_ to cover the fee for a \_\_\_\_\_ month extension is enclosed.

A check in the amount of \$\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Scott D. Miller  
Attorney for Applicant

Registration No. 32,533

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30 Rockefeller Plaza  
New York, New York 10112-3801  
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SDM\mm

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Not  
Approved  
JVC  
12-6-01  
016842985

L-9  
10-12-01  
#10

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:

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) Examiner: L. Cirić

) Group Art Unit: 3743

) October 9, 2001

Commissioner for Patents  
Washington, D.C. 20231

REQUEST TO MAKE DRAWING CHANGES

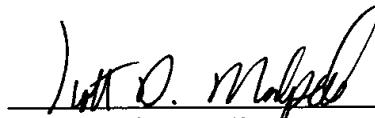
Sir:

Enclosed, in accordance with U.S. Patent and Trademark Office Practice, are copies of proposed drawing changes shown in red ink, wherein Figure 1 is amended to include a semiconductor manufacturing equipment, inspection equipment and measuring equipment labelled in rectangular box form.

Approval of the drawing corrections by the Examiner is respectfully requested.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants

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